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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Kouji HAGA et al.**

Group Art Unit: 1765

Application Number: **10/524,064**

Examiner: **Lynette T. UMEZ ERONINI**

Filed: **February 8, 2005**

Confirmation Number: **4436**

For: **POLISHING SLURRY FOR CHEMICAL MECHANICAL POLISHING AND
METHOD FOR POLISHING SUBSTRATE**

Attorney Docket Number: **052107**

Customer Number: **38834**

AMENDMENT UNDER 37 C.F.R. §1.111
AND
RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

August 17, 2007

Sir:

This Amendment is filed in response to the Office Action dated April 3, 2007 and in response to the "NOTICE OF NON-COMPLIANT AMENDMENT" dated July 17, 2007. Claim 8's status identifier should be "Currently amended".

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.